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				<u>Application Number</u>	Not Yet Assigned
				<u>Filing Date</u>	February 25, 2002
				<u>First Named Inventor</u>	Shunpei YAMAZAKI et al
				<u>Group Art Unit</u>	Not Yet Assigned
				<u>Examiner Name</u>	Not Yet Assigned
Sheet	1	of	1	<u>Attorney Docket Number</u>	740756-2443

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

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¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

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Sheet

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of

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Complete if Known

Application Number	10/081,767
Filing Date	February 25, 2002
First Named Inventor	Shunpei YAMAZAKI et al.
Art Unit	2813
Examiner Name	Thanh Nguyen
Attorney Docket Number	740756-2443

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U.S. TRADEMARK OFFICE**U.S. PATENT DOCUMENTS**

Examiner Initials ¹	Cite No. ¹	U.S. Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number - Kind Code ² (if known)			
TW		US-5,529,937	06/25/1996	Zhang et al.	
		US-5,569,610	10/29/1996	Zhang et al.	
		US-5,639,698	06/17/1997	Yamazaki et al.	
		US-5,663,077	09/02/1997	Adachi et al.	
		US-5,773,327	06/30/1998	Yamazaki et al.	
		US-5,824,573	10/20/1998	Zhang et al.	
		US-5,879,977	03/09/1999	Zhang et al.	
		US-5,923,997	07/13/1999	Mitanaga et al.	
		US-5,953,597	09/14/1999	Kusumoto et al.	
YW		US-6,319,761 B1	11/20/2001	Zhang et al.	
		US-			

FOREIGN PATENT DOCUMENTS

Examiner Initials ¹	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T ²
		Country Code ³ Number ⁴ Kind Code ² (if known)				

OTHER PRIOR ART – NON PATENT LITERATURE DOCUMENTS

Examiner Initials ¹	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²

Examiner Signature: *[Signature]* Date Considered: 7/28/03

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¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

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Patent and Trademark Office

Atty Docket 0756-2443

Serial No. 10/081,767

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INFORMATION DISCLOSURE STATEMENT

Applicants: Shunpei YAMAZAKI et al.

Filing Date: February 25, 2002

Group Art Unit: 2812

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
TW	2001/0003659	06/14/2001	Aya et al.			
/	5,854,096	12/29/1998	Ohtani et al.			
/	6,184,068	02/06/2001	Ohtani et al.			
TW	6,326,248	12/04/2001	Ohtani et al.			

OTHER DOCUMENT (Including Author, Title, Date, Pertinent Pages, Etc.)

Examiner Initial	Other Document Description
TW	Kimura et atl., "Device Simulation of Interface Roughness in Laser-Crystallized p-Si TFT's", pp. 263-266, 1999, AM-LCD
/	Abe et al., "High-Performance Poly-Crystalline Silicon TFTs Fabricated Using the SPC and ELA Methods", pp. 85-88, July 9-10 1998, AM-LCD
/	Specifications and Drawings for Application Serial No. 10/078,240, "Method of Manufacturing a Semiconductor Device" Filing Date: February 20, 2002, Inventors: Shunpei YAMAZAKI et al.
TW	Specifications and Drawings for Application Serial No. 10/056,054, "Method for Manufacturing a Semiconductor Device"

Examiner <i>[Signature]</i>	Date Considered <i>7/28/03</i>
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